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On JANUARY 26, 2005

TOWNSEND and TOWNSEND and CREW LLP

By: Eleanor J. Taylor

**AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE -  
EXAMINING GROUP 2812**

PATENT  
Attorney Docket No.: 016301-045600US  
AMAT No.: 6381 DSM/PMD/JW  
Client Ref. No.: A6381/T45600

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

ZHENG YUAN et al.

Application No.: 10/090,103

Filed: February 27, 2002

For: PROCESS FOR FORMING  
SILICON OXIDE MATERIAL

Confirmation No. 4419

Examiner: Ron Everett Pompey

Technology Center/Art Unit: 2812

**AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2812**

**Mail Stop AF**  
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P.O. Box 1450  
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Sir:

In response to the Final Office Action mailed on the above-referenced application, please enter the following amendments and remarks. A petition for a one month extension of time for consideration of this amendment is included herein.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.